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PATENT  
Customer No. 22,852  
Attorney Docket No. 2887.0259-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Junji SUGAMOTO et al. ) Group Art Unit: 2891  
)  
Application No.: 10/706,090 ) Examiner: LEE, Granvill D.  
)  
Filed: November 13, 2003 )  
)  
For: SEMICONDUCTOR WAFER ) Confirmation No.: 7292  
TREATMENT METHOD, )  
SEMICONDUCTOR WAFER )  
INSPECTION METHOD, )  
SEMICONDUCTOR DEVICE )  
DEVELOPMENT METHOD AND )  
SEMICONDUCTOR WAFER )  
TREATMENT APPARATUS )

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants petition for a third month extension of time to reply to the Office Action of March 23, 2005. A fee of \$570.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

09/23/2005 JADD01 00000022 10706090

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570.00 OP

Dated: September 22, 2005

By: \_\_\_\_\_

Richard V. Burgujian  
Reg. No. 31,744